

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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**Title of  
Invention**

DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE  
FABRICATION

Application Number :

Confirmation Number:

First Named Applicant: June Cline

Attorney Docket Number: BUR920040122US1

Art Unit:

Examiner:


Search string: ( 6676800 or 6318384 or 6235214 or 6127278 or 6020269 or 5807789 ).pn


## US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
EC	1	6676800	2004-01-13	Festa et al			
I	2	6318384	2001-11-20	Khan et al			
I	3	6235214	2001-05-22	Deshmukh et al			
I	4	6127278	2000-10-03	Wang et al			
I	5	6020269	2000-02-01	Wang et al			
✓	6	5807789	1998-09-15	Chen et al			

## Signature

Examiner Name	Date
	7/5/05

	ATTY DOCKET NO. <b>BUR920040122US1</b>	APPLICATION NO. <b>10/711,953</b>
	APPLICANT(S) <b>June Cline et al.</b>	
	FILING DATE <b>10-15-2004</b>	GROUP ART UNIT

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**U.S. PATENT APPLICATION PUBLICATIONS**

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**FOREIGN PATENT DOCUMENTS**

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

<b>EC</b>			HANDBOOK OF THIN FILM TECHNOLOGY, Edited by Leon I. Maissel and Reinhard Glang, Copyright: 1970, p. 7-44.

EXAMINER 	DATE CONSIDERED <b>7/5/05</b>
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.